

Notice of References CitedApplication No.
08/825,360Applicant(s)
Liao et al.Examiner
Quach, T.Group Art Unit
2814

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U.S. PATENT DOCUMENTS

	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS
A	5,723,382	3/1998	Sandhu et al.	438	653
B					
C					
D					
E					
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G					
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J					
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M					

FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	NAME	CLASS	SUBCLASS
N						
O						
P						
Q						
R						
S						
T						

NON-PATENT DOCUMENTS

	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	DATE
U	Suguro, K., et al., "Barrier Metal Between Tungsten and Silicon for High Temperature Processing," Applied Surface Science, Vols. 41-42, 1989, pp. 2277-281	1989
V		
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